



141B w/Dug.
5/13/03
D. Bell

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Katsura Otaki

Group Art Unit: 2877

Application No.: 09/780,414

Examiner: S. Turner

Filed: February 12, 2001

Docket No.: 108598

For: POINT DIFFRACTION INTERFEROMETER FOR MEASURING PROFILE
IRREGULARITIES (AS AMENDED)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action mailed February 13, 2003, please amend the above-identified application as follows:

Amendments to the Specification;

Amendments to the Claims are reflected in the listing of claims;

Amendments to the Drawings include an attached replacement sheet; and

Remarks.

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U.S. PATENT & TRADEMARK OFFICE